

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	32511	(thin adj film adj transistor\$1) or TFT	US-PGPUB; USPAT	OR	OFF	2005/02/15 17:23
L2	179313	1 and gate.clm. or electrode.clm.	US-PGPUB; USPAT	OR	OFF	2005/02/15 17:23
L3	17084	1 and (gate.clm. or electrode.clm.)	US-PGPUB; USPAT	OR	OFF	2005/02/15 17:23
L4	2584	3 and (photoresist.clm. or mask.clm. or resist.clm.)	US-PGPUB; USPAT	OR	OFF	2005/02/15 17:24
L5	2028	4 and (pattern\$3.clm. or etch\$3.clm.)	US-PGPUB; USPAT	OR	OFF	2005/02/15 17:24
L6	795	5 and (edge\$1 or (thin adj out) or staircase\$1)	US-PGPUB; USPAT	OR	OFF	2005/02/15 17:25
L7	117	6 and ((thin\$3 near10 edge\$1) or (thin adj out) or staircase)	US-PGPUB; USPAT	OR	OFF	2005/02/15 17:27
L8	53	6 and ((thin\$3 near3 edge\$1) or (thin adj out) or staircase)	US-PGPUB; USPAT	OR	OFF	2005/02/15 18:58
L9	3	8 and (((thin adj out) or staircase) with (pattern\$3 or etch\$3))	US-PGPUB; USPAT	OR	OFF	2005/02/15 18:51
L10	0	8 and (thin adj out)	US-PGPUB; USPAT	OR	OFF	2005/02/15 18:58
L11	9	8 and staircase\$1	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:02
L12	95326	transistor\$1 and gate.clm.	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:02
L13	12972	12 and ("etch\$3." "clm." or pattern\$3.clm.)	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:02
L14	19483	12 and (etch\$3.clm. or pattern\$3.clm.)	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:03
L15	15872	14 and (photoresist or resist or mask)	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:03
L16	2373	14 and ((photoresist or resist or mask) near10 thin\$5)	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:04
L17	2373	15 and ((photoresist or resist or mask) near10 thin\$5)	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:04
L18	384	17 and ((photoresist or resist or mask) near10 edge\$1)	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:05
L19	323	18 and (photoresist.clm. or mask.clm. or resist.clm. or edge\$1.clm.)	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:13
L20	77	19 and (thin\$3 near8 edge\$1)	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:14
L21	56	20 and edge\$1.clm.	US-PGPUB; USPAT	OR	OFF	2005/02/15 19:14